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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASAKI MIZUTANI, ET AL.

Application No.: 09/813,137

Filed: March 21, 2001

For: METHOD OF PRODUCING
SEMICONDUCTOR THIN
FILM AND METHOD OF
PRODUCING SOLAR CELL
USING SAME

Examiner: J. L. Goff II

Group Art Unit: 1733

February 4, 2003

8C/KW
2/12/03

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action dated November 4, 2002 (Paper No. 7),
please amend the above-identified application, as follows:

IN THE CLAIMS:

Please cancel Claims 20, 22 and 28 without prejudice or disclaimer of the
subject matter presented therein. Please amend Claims 19, 21, 27 and 30 as follows. A

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner
of Patents and Trademarks, Washington, D.C. 20231
on Feb 4, 2003
(Date of Deposit)

Damond E. Vadnais, Reg no. 52,310
Name of Attorney for Applicant

Damond E. Vadnais Feb. 4, 2003
Signature Date of Signature